

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:

Jiro YUGAMI et al

Serial No.:

Unassigned

Filed:

December 7, 2001

For:

SEMICONDUCTOR DEVICE AND PROCESS FOR

PROCESSING THE SAME

Art Unit:

Unassigned

INFORMATION DISCLOSURE STATEMENT

December 7, 2001

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In connection with the above-identified application and pursuant to Applicant's duty of disclosure, enclosed please find three (3) documents corresponding to the above-identified application. Further enclosed is a List, on a form substantially equal to Form PTO-1449, of these documents.

This Information Disclosure Statement is being submitted prior to a first Office Action on the merits in the above-identified application. Accordingly, requirements of 37 CFR 1.97(b) are satisfied.

To the extent that the enclosed documents are not in English, it is respectfully submitted that the requirements of 37 CFR 1.98(a) are satisfied by the enclosed English Abstracts.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR 1.97 and 1.98 have been satisfied, in connection with all documents of the enclosed list. Accordingly, consideration of the listed documents, upon examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper, or credit any overpayment of fees, to the deposit account of Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (520.40885X00).

Respectfully submitted,

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Attachments